Docket No.: 060188-0751 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshiharu HIDAKA, et al. ¥

Application No.: 10/754,518

Filed: January 12, 2004

Customer Number: 20277

Confirmation Number: 8259

Group Art Unit: 2814

Examiner: Thao X. Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND

METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

## INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

## REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND BEFORE PAYMENT OF ISSUE FEE

The undersigned hereby requests consideration and entry of this Information Disclosure

Statement and accompanying references under 37 CFR 1.97(d).

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10/754,518

**CERTIFICATION PARAGRAPH** 

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application

office action and its relevance discussed therein. A copy of the foreign office action, is attached

for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Please recognize our Customer No. 20277

as our correspondence address.

Ramyar M. Farid

Registration No. 46,692

600 13<sup>th</sup> Street, N.W. Washington, DC 20005-3096

Phone: 202.756.8000 RMF:gav

Facsimile: 202.756.8087

Date: January 9, 2006

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JAN 0 9 7 (PTO-1449)  U.S.				FILING DATE  January 12,	FILING DATE  January 12, 2004					
U.S. PATENT DOCUMENTS										
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Dat MM-DD-YYYY			ges, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
		US	6,439,969 B1	08/27/2002	Koma et al.	Cor	responds to KR 2000-0076805			
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.).										
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EXAMINER						DATE CONSIDERED				

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.